Application No.: 10/772.510 Filed: February 5, 2004

Amendment dated: January 30, 2008 Reply to Office Action of October 30, 2007

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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re:

Detlef Michelsson

Confirmation

5672

No:

Serial No:

10/772.510

Art Unit:

2624

Filed:

February 5, 2004

Examiner:

Fujita. Katrina R.

orter, 108

For:

Method and Apparatus for

Examining Semiconductor Wafers in a Context of DIE/SAW Design

Customer No.:

29127

Attorney

21295.74 (H5742US)

Docket No.

## **AMENDMENT AFTER FINAL ACTION**

Fax: 571-273-8300

Mail Stop AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the pending final Office Action, mailed October 30, 2007 (Paper No. 20071025), please amend the above-captioned application as follows:

Amendments to the Claims are reflected in the listing of claims in the Amendments to the Claims section.

Reconsideration is requested in view of the remarks set forth in Remarks/Arguments section.